Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	5420	(156/345.1-345.55).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:35
L2	4948	(438/5-18).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:35
L3	857	(356/36,625).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:35
L4	820	(356/630-632).CCLS.	US-PGPUB; USPAT; USOCR	OR .	OFF	2005/08/08 12:35
L5	243	(356/635).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:36
L6	1070	(250/559.19,559.2,559.22,559.24, 559.27).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:36
L7	285	(359/509).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:36
L8	6984	(wafer semiconduct\$) same (thickness\$ near (measur\$5 obtain\$3 determin\$ calculat\$))	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/08 12:39
L9	742	(1 2 3 4 5 6 7) and 8	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/08 12:39
L10	55	9 and ((inert nitrogen) near gas)	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/08 13:14
L14	1	("5393624").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 12:43
L15	1	("5818596").URPN.	USPAT .	OR	OFF	2005/08/08 13:10
L16	10	(reference near slice) same (wafer semiconduct\$)	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/08 13:10
L17	19	9 and (display\$ near data)	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/08 13:12
L18	1492	(356/72,73).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/08 13:13
L19	41	8 and 18	US-PGPUB; USPAT; USOCR	OR .	OFF	2005/08/08 13:13

L20	2	19 and ((inert nitrogen) near gas)	US-PGPUB;	OR	ON	2005/08/08 13:15
			USPAT;			
			USOCR			